

<b>Notice of References Cited</b>	Application/Control No. 10/015,868	Applicant(s)/Patent Under Reexamination HOOVEN, MICHAEL D.	
	Examiner Victoria W. Chen	Art Unit 3739	Page 1 of 1

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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